

**Amendments to the Specification:**

Please replace the paragraph beginning on page 15, line 5, with the following rewritten paragraph:

Fig. 9 is a sectional diagram showing a schematic structure of the electroluminescent element fabrication apparatus used in this example. A resin thin film 300 having PPV, which was formed by forming a film of PEDOT-PSS on a glass substrate having the ITO, applying a poly (p-xylenethiopheniumchloride) solution onto it and calcining, was used. Meanwhile, a sublimation source 240 having ~~PBT disposed~~PBD disposed (5 mm thick, 10 mm wide, 400 mm long) was produced. The resin thin film 300 of the PEDOT-PSS/PPV having the ITO was placed in an airtight container 110, and the sublimation source 240 was disposed in another airtight container 120. The two airtight containers 110, 120 were mutually connected through a pipe and a valve 195. The airtight container 110 in which the resin thin film 300 of the PEDOT-PSS/PPV having the ITO was disposed had a stainless steel or aluminum outer wall and a structure (not shown) which could be divided into upper and lower sections for loading/unloading of the resin thin film 300.